Docket No.: P8375.0002 (PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Hidemitsu Aoki, et al.

Application No.: Not Yet Assigned

Group Art Unit: N/A

Filed: Concurrently Herewith

Examiner: Not Yet Assigned

For:

METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE AND APPARATUS FOR CLEANING

SUBSTRATE

INFORMATION DISCLOSURE STATEMENT (IDS)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Pursuant to 37 CFR 1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO/SB/08. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

Timing of Filing of the Information Disclosure Statement:

X	This IDS is being filed before the First Office Action ¹ .
	This IDS is being filed after the issuance of the First Office Action but before the
	issuance of a Final Office Action ² .

¹ The IDS should, where possible, include a certification under 37 CFR § 1.97(e).

² The IDS must include either a certification under 37 CFR § 1. 97(e) or the fee set forth in 37 CFR § 1.17(p).

³ The IDS must include both a certification under 37 C.F.R. §1.97(e) and the fee set forth in 37 C.F.R. §1.17(p).

Materiality:

While the information and references disclosed in this Information Disclosure Statement may be "material" pursuant to 37 CFR 1.56, this submission is not intended to constitute an admission that any patent, publication or other information referred to therein is "prior art" for this invention unless specifically designated as such.

In accordance with 37 CFR 1.97(g), the filing of this Information Disclosure Statement shall not be construed to mean that a search has been made or that no other material information as defined in 37 CFR 1.56(a) exists. It is submitted that the Information Disclosure Statement is in compliance with 37 CFR 1.98 and the Examiner is respectfully requested to consider the listed references.

The Director is hereby authorized to charge any deficiency in the fees filed, asserted to be filed or which should have been filed herewith (or with any paper hereafter filed in this application by this firm) to our Deposit Account No. 50-2215, under Order No. P8375.0002. A duplicate copy of this paper is enclosed.

Dated: October 8, 2003

Respectfully submitted,

Mark I Thronson

Registration No.: 33,082

DICKSTEIN SHAPIRO MORIN &

OSHINSKY LLP

1177 Avenue of the Americas

41st Floor

New York, New York 10036-2714

(212) 835-1400

Attorney for Applicant

P8375.0002

Approved for use through 07/31/2006. OMB 0651-0031

U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE

Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number. Complete if Kn wn Substitute for form 1449A/B/PTO Application Number Not Yet Assigned INFORMATION DISCLOSURE Filing Date Concurrently Herewith STATEMENT BY APPLICANT First Named Inventor Hidemitsu Aoki Art Unit N/A (Use as many sheets as necessary) Examiner Name Not Yet Assigned

Attorney Docket Number

	U.S. PATENT DOCUMENTS							
Examiner	Cita	Document Number	Publication Date	Name of Patentee or	Pages, Columns, Lines, Where			
Initials*	Cite No. ¹	Number-Kind Code ² (if known)	1414 00 10004		Applicant of Cited Document	Relevant Passages or Relevant Figures Appear		
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	FOREIGN PATENT DOCUMENTS									
Examiner Initials*	Cite No.1	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear					
		Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)								
	ВА	JP-11-214350	08-06-1999		- -	_				
	BB	JP-11-204491	07-30-1999			一				
	ВС	JP-2000-058498	02-25-2000							

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. \(^1\) Applicant's unique citation designation number (optional). \(^2\) See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. \(^3\) Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). \(^4\) For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. \(^5\) Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. \(^6\) Applicant is to place a check mark here if English language Translation is attached.

NON PATENT LITERATURE DOCUMENTS							
Examiner Initials	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²				

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